

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yasunori Ito, et al.

Serial No.: 10/640,850

Filed: August 13, 2003

For: METHOD OF PRODUCING  
CERAMIC THERMISTOR  
CHIPS

Group Art Unit: 1795

Confirmation No.: 9131

Examiner: H. D. Wilkins III

Attorney Docket: MURTP083D1

**CERTIFICATE OF EFS-WEB  
TRANSMISSION**

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on July 3, 2008.

Signed: /dn/  
Deborah Neill

**AMENDMENT "H"**

Commissioner for Patents  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action dated March 6, 2008 in the above-referenced application, regarding which it is requested with the payment of a fee to extend the period for response by one month to July 6, 2008, applicant submits the following REMAKRS together with the current status of the claims section: